



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Attorney Docket No. 249/258

In re patent application of

Yeong-kwan KIM et al.

Group Art Unit: 2822

Serial No. 09/902,607

Examiner: K.L. Rose

Filed: July 12, 2001

For: SEMICONDUCTOR DEVICE HAVING THIN FILM FORMED BY ATOMIC
LAYER DEPOSITION AND METHOD FOR FABRICATING THE SAME

5/Election
8/27/02
R. Wal

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
Washington, D.C. 20231

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TECHNOLOGY CENTER 2800

Sir:


In response to the Office Action dated July 29, 2002, applicants hereby elect the claims of Group II, claims 16-35, for prosecution in the subject application.

Applicants, of course, reserve the right to file a divisional application covering the subject matter of the non-elected claims.

Receipt of the initial Office Action on the merits is awaited.

Respectfully submitted,

Date: August 14, 2002


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PETITION and
DEPOSIT ACCOUNT CHARGE AUTHORIZATION

This document and any concurrently filed papers are believed to be timely. Should any extension of the term be required, applicant hereby petitions the Director for such extension and requests that any applicable petition fee be charged to Deposit Account No. 50-1645.

If fee payment is enclosed, this amount is believed to be correct. However, the Director is hereby authorized to charge any deficiency or credit any overpayment to Deposit Account No. 50-1645.

Any additional fee(s) necessary to effect the proper and timely filing of the accompanying-papers may also be charged to Deposit Account No. 50-1645.